



PATENT
81208-024625

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

NIELSEN, HENRIK K. ET AL.

Serial No.: 09/195,533

Filed: November 18, 1998

For: DETECTION SYSTEM FOR
NANOMETER SCALE TOPOGRAPHIC
MEASUREMENTS OF REFLECTIVE
SURFACES

Group No.: 2877

Examiner: R. ROSENBERGER

10/11/01
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C. Stony
1-4-01

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Assistant Commissioner For Patents
Washington, D.C. 20231

PETITION FOR EXTENSION OF TIME

Dear Sir:

In accordance with Rule 136, Applicant respectfully petitions the Commissioner for a one month extension of time extending to December 26, 2000, the period for response to the Office Action dated August 25, 2000. A check for \$110.00 and the responsive paper(s) are attached.

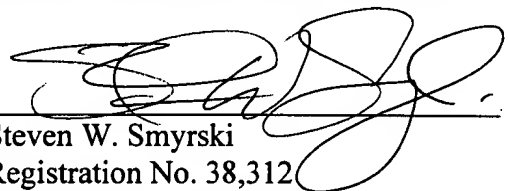
Please charge any insufficiency or credit any overpayment to Deposit Account No. 03-3975. A copy of this petition is enclosed.

Respectfully submitted,

PILLSBURY MADISON & SUTRO LLP

Dated: December 26, 2000

By:


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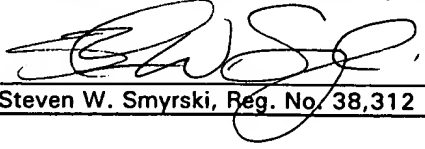
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I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington D.C. 20231, on 12/26/00.

By:


Steven W. Smyrski, Reg. No. 38,312